

# 9<sup>th</sup> IFAST WP9 meeting

(i.FAST 2<sup>nd</sup> Annual meeting)



Bundesministerium  
für Bildung  
und Forschung

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LOT, Institut für Werkstofftechnik, Universität Siegen

(Novel accelerator technology for efficient light sources NOVALIS)

17-21 Apr 2023, Trieste, Italy

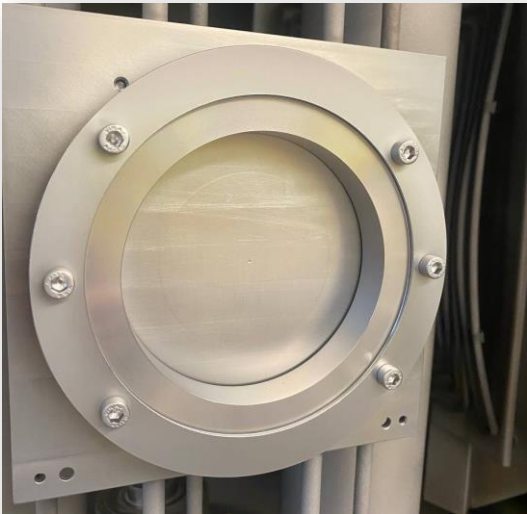
## Coating of RaSTA parts

Pre-treatment with ultrasonic bath (ammonia-based)

1<sup>st</sup> Proc. ID: 20210729 **4 $\mu$ m Nb** (with MF etching)

2<sup>nd</sup> Proc. ID: 20210801 **12  $\mu$ m Nb**

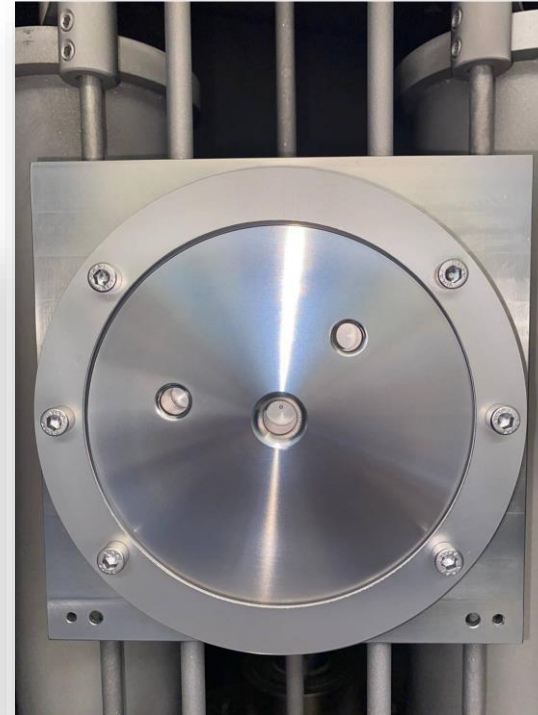
**CF125 Cavity flange**



**QPR sample adapter**



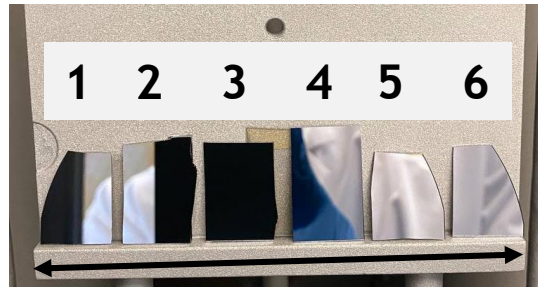
**CF125 Top flange**



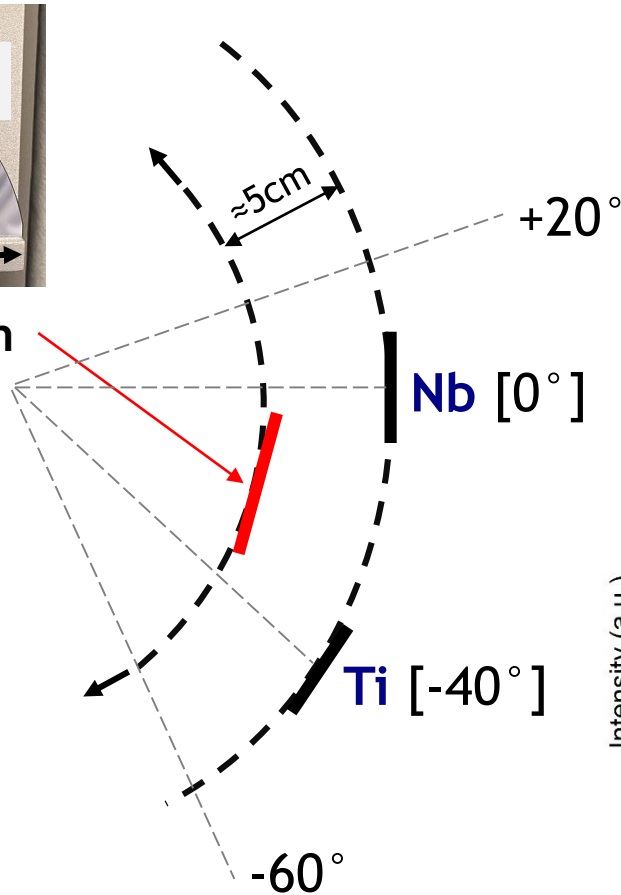
**Adapter CF125 to CF100**



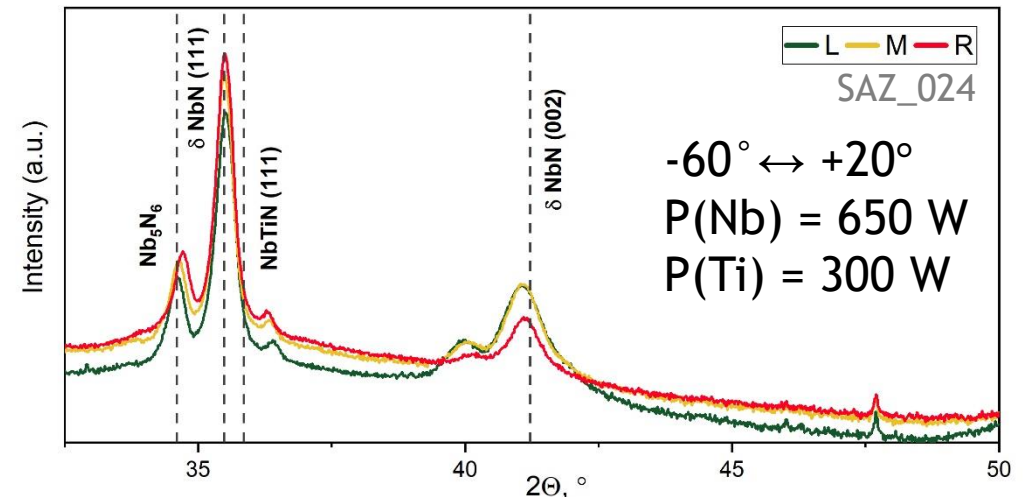
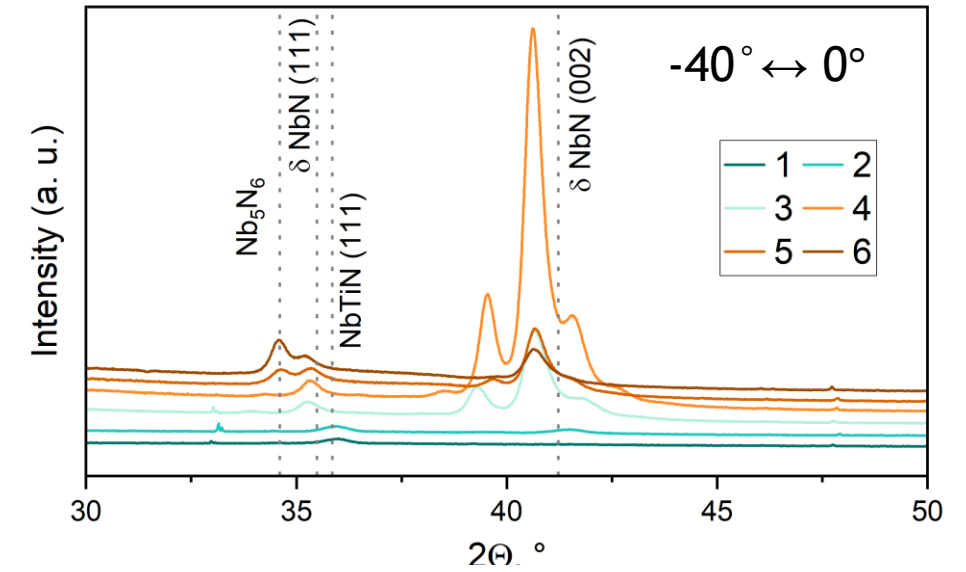
# Co-sputtering of NbTiN: rocking angle



Sample stage 120mm



Rocking angle	
-40	0
-45	+5
-55	+15
-60	+20
-65	+25
-70	+30

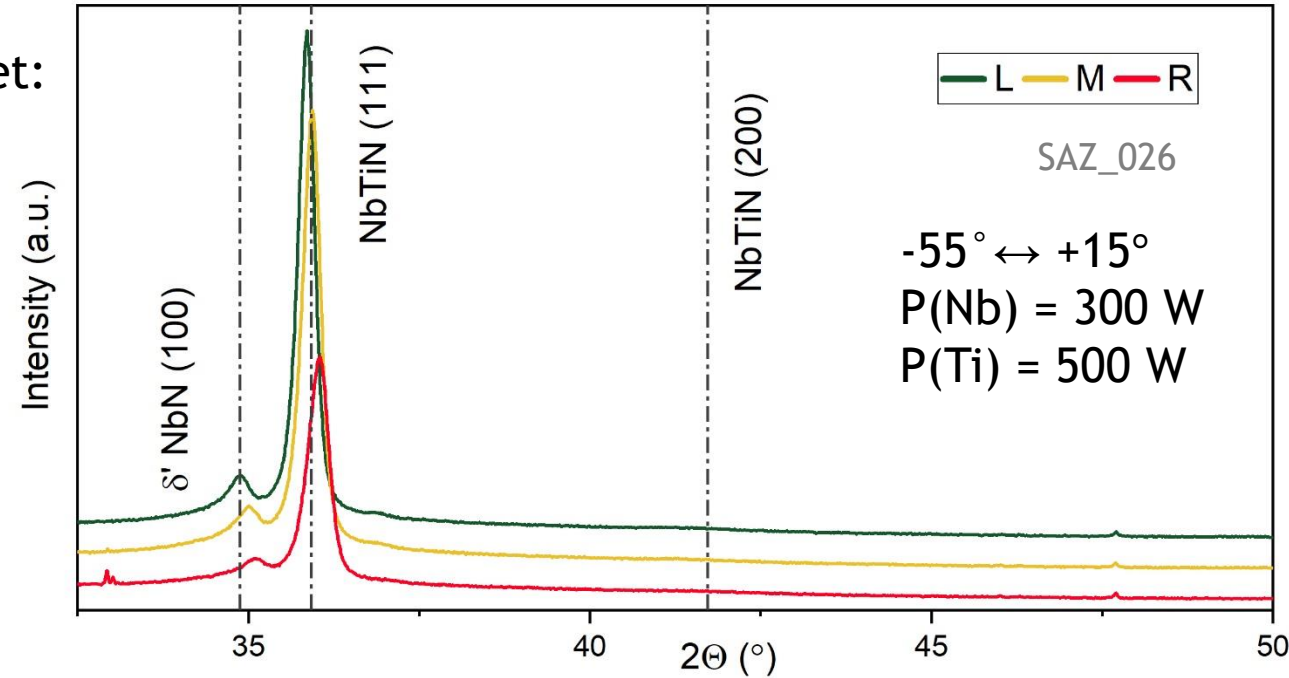


# Co-sputtering of NbTiN: phase mixing



Too much power on Nb target:

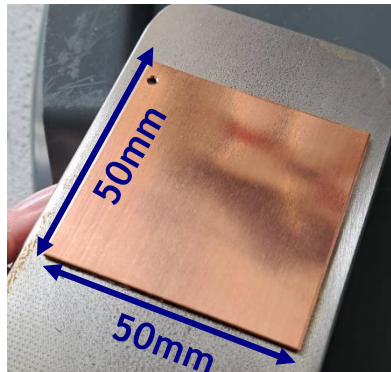
- Delamination of films
- Unstable work of HiPIMS
- Growth of NbN phases



Change the Ti/Nb power ratio:

- Optimum around 500W/300W
- Rocking angle [-60° ↔ +20°]
- Needs to vary other parameters: p, Ar/N<sub>2</sub>, bias...

## Sample preparation



untreated



2000 grit



4000 grit



Diamond polishing paste (3 μm)

@ Yvonne

- Development of the surface pre-treatment (mechanical polishing) for large **Cu substrates**
- Electropolishing of **Cu substrates**: standard procedure?
- **Nb substrates**: still waiting for permission from the safety-at-work department for EP

**THANK YOU FOR YOUR ATTENTION!**

## In addition

HiPIMS-NbN multi-layer (SS and SIS) structures: what were the latest samples and which of them is of interest?

SEM of NbTiN:

